

03500.013395.2

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)	
	:	
KEISHI SAITO, ET AL.	)	
	:	
Application No.: Not Yet Assigned	)	
	:	
Filed: Concurrently Herewith	)	
	:	
For: SEMICONDUCTOR ELEMENT	)	
AND ITS MANUFACTURING	:	
METHOD	)	July 23, 2003

**This application is a divisional  
under 37 C.F.R. § 1.53(b) of  
U.S. Patent Appln. No. 09/839,891**

Mail Stop Patent Application  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

CLAIM TO PRIORITY

Sir:

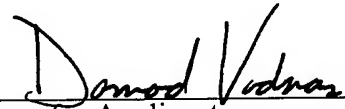
Applicants hereby claim priority under the International Convention and all rights to which they are entitled under 35 U.S.C. § 119 based upon the following Japanese priority applications:

Japan 10-065287, filed March 16, 1998; and  
Japan 10-066854, filed March 17, 1998.

Certified copies of the priority documents were submitted in grandparent  
Application No. 09/266,829.

Applicants' undersigned attorney may be reached in our Costa Mesa,  
California office by telephone at (714) 540-8700. All correspondence should continue to  
be directed to our address given below.

Respectfully submitted,

  
\_\_\_\_\_  
Attorney for Applicants

Registration No. 52,310

FITZPATRICK, CELLA, HARPER & SCINTO  
30 Rockefeller Plaza  
New York, New York 10112-3801  
Facsimile: (212) 218-2200

CA\_MAIN 66531 v 1